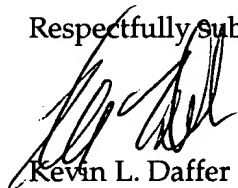


Support for these changes may be found, for example, on page 17, lines 18-23 of the Specification. "Ionizing element 320 is preferably arranged between target 302 and pedestal 306, and is preferably configured to ionize at least a portion of the metal atoms sputtered from target 302 before the metal ions reach pedestal 306. More preferably, ionizing element 320 includes induction coil 310 configured around wetting layer deposition chamber 300 and mounted near or on sidewalls 311 of the chamber. The induction coil may turn around the chamber any number of times." Accordingly, these changes do not present new matter.

If the Examiner has any questions, comments, or suggestions, the undersigned attorney earnestly requests a telephone conference. The Commissioner is authorized to charge any fees, which may be required, or credit any overpayment, to Conley, Rose & Tayon, P.C. Deposit Account No. 501505/5298-03500.

Respectfully submitted,



Kevin L. Daffer
Reg. No. 34,146
Attorney for Applicant(s)

Conley, Rose & Tayon, P.C.
P.O. Box 398
Austin, TX 78767-0398
Ph: (512) 476-1400
Date: July 12, 2001
MEH